

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 30020-301001	Application No. 10/758,710
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Martin W. Rupich et al.	
		Filing Date 1/16/2004	Group Art Unit 1793
(37 CFR §1.98(b))			

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	6083885	7/2000	Weinstein			
	AB	2003/0054105	3/2003	Hammond			
	AC	5863869	1/1999	Chaudhari			

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes No

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AD	Li, et al. "Positron annihilation study on the stress-field pinning mechanism in (Eu, Y)-123 superconductors" <i>Physica C</i> , Vol. 314, No. 1-2, (March 1, 1999) pages 55-68
	AE	Lu, et al. "High Density, Ultrafine Precipitates in YBa ₂ Cu ₃ O _{7-x} Thin Films Prepared by Plasma-enhanced metalorganic Chemical Vapor Deposition" <i>Applied Physics Letters</i> . Vol 60 no 10 (March 9, 1992) pages 1265-7
	AF	Caplin, et al. "The Current-Voltage Relationship in Crystals and Conductors" <i>Physica C</i> . Vol 401 no 1-4. (January 15, 2004) pages 1-6

Examiner Signature	/Paul Wartalowicz/	Date Considered	02/10/2011
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			